

#17/C PA  
w/E  
**PATENT APPLICATION**

**RESPONSE UNDER 37 CFR §1.116 11-27-03**  
**EXPEDITED PROCEDURE**  
**TECHNOLOGY CENTER ART UNIT 2825**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of

Satoshi TAKANO

Group Art Unit: 2825

Application No.: 09/819,690

Examiner: G. Lee

Filed: March 29, 2001

Docket No.: 109107

For: SEMICONDUCTOR MANUFACTURING METHOD, SUBSTRATE PROCESSING  
METHOD, AND SEMICONDUCTOR MANUFACTURING APPARATUS

**AMENDMENT AFTER FINAL REJECTION UNDER 37 CFR §1.116**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the June 3, 2003 Office Action, the shortened statutory period for reply  
being extended by the attached Petition for Extension of Time, please consider the following:

**Amendments to the Claims** as reflected in the listing of claims;

**Remarks.**

Do NOT ENTER 6/17/03

Do NOT ENTER